



IFW

Docket No.: 050389-0052

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Chihiro KAWAI, et al.	:	Confirmation Number: 3373
Application No.: 10/500,975	:	Group Art Unit: 2811
Filed: July 08, 2004	:	Examiner: Not Yet Assigned
For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME		

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

Please note that the reference JP 2683452 was previously submitted to the Patent and Trademark Office on July 8, 2004. The reference was incorrectly listed as being published on August 8, 1997 when it was actually registered on this date. The publication date of JP 2683452 is

10/500,975

corrected listed on the attached form PTO-1449 as November 26, 1997. The reference WO 94/27929 corresponds to JP 2683452 and is being cited to provide the Examiner with an English Abstract.

CERTIFICATION PARAGRAPH

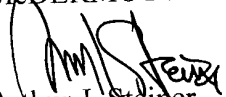
The undersigned certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each reference was cited in a corresponding foreign application search report and its relevance discussed therein. A copy of the foreign search report, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

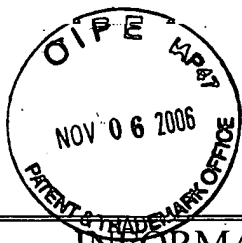


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**Please recognize our Customer No. 20277
as our correspondence address.**



SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 050389-0052		SERIAL NO. 10/500,975	
				APPLICANT Chihiro KAWAI, et al.			
				FILING DATE July 08, 2004		GROUP 2811	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 5,939,732	08/17/1999	Kurtz et al.			
		US 5,726,464	03/10/1998	Kumomi et al.			
		US 5,331,180	07/19/1994	Yamada et al.			
		US					
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number 4 - Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No	
		EP 0 767 486 A2	04/09/1997	CANON KABUSHIKI KAISHA		X	
		EP 0 653 392 A1	05/17/1995	SUMITOMO ELECTRIC INDUSTRIES, LTD.		X	
		JP 2683452	11/26/1997	SUMITOMO ELECTRIC INDUSTRIES, LTD.	Corresponds to WO 94/27929		X
		WO 94/27929	12/08/1994	SUMITOMO ELECTRIC INDUSTRIES, LTD.	Corresponds to JP 2683452	JAPAN (w/ English Abstract)	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		Supplementary European Search Report for Application No. EP 03 74 1323 dated October 5, 2006					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.